INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 7, 2026

IGI Report Number	LG764695855
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CONCAVE SQUARE MODIFIED BRILLIANT
Measurements	5.86 X 5.83 X 4.13 MM

GRADING RESULTS

Carat Weight	1.07 CARAT
Color Grade	D
Clarity Grade	VS 1

ADDITIONAL GRADING INFORMATION

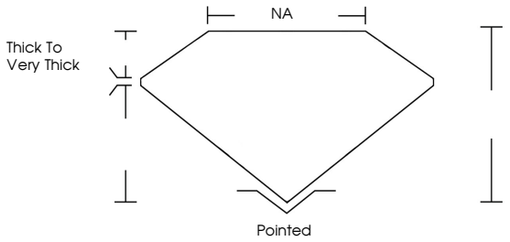
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG764695855

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG764695855

Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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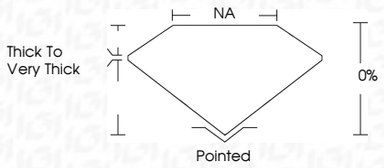
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IGI

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CONCAVE SQUARE MODIFIED BRILLIANT
5.86 X 5.83 X 4.13 MM
Carat Weight 1.07 CARAT
Color Grade D
Clarity Grade VS 1
Depth 0%
Table NA
Girdle Thick To Very Thick
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG764695855
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa